

Application/Control No.	Applicant(s)/Patent under Reexamination	
10/682,657	POLONKA, JAC	K
Examiner	Art Unit	
LAYLA SOROUSH	1617	

SEARCHED						
	SEARCHED					
Class	Subclass	Date	Examiner			

INTERFERENCE SEARCHED				
bclass	Date	Examiner		

SEARCH N (INCLUDING SEAR)	IOTES CH STRATEGY	<b>)</b>
	DATE	EXMR
see EAST search history	9/17/2008	LS